

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Mariner et al.

Examiner: Fiorito, James

Serial Number: 10/759,582

Filed: 01/16/2004

Confirmation Number: 7994

Art Unit: 1763

For: **Wafer Handling Apparatus and Method of Manufacturing Thereof**

VIA FACSIMILE: (571) 273-8300

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

RESPONSE

Sir:

This Amendment is submitted in response to the Office Action dated August 31, 2006, for which a Request for Continuing Examination and a Petition for Extension of Time for two months are submitted herewith. Please amend the Application as follows: